

Application Data Sheet

Application Information

Filing Date:: 7/18/2003 12:00:00AM
Application Type:: Utility
Subject Matter:: Utility
CD_ROM or CD-R?:: None
Title:: EXPOSURE APPARATUS, MAINTENANCE
METHOD THEREFOR, SEMICONDUCTOR DEVICE
MANUFACTURING METHOD USING THE
APPARATUS, AND SEMICONDUCTOR
MANUFACTURING FACTORY
Attorney Docket Number:: 00862.022435.1
Total Drawing Sheets:: 19
Small Entity?:: No
Secrecy Order in Parent Appl.?:: No

Applicant Information

Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Kiyoshi
Family Name:: ARAKAWA
City of Residence:: Tochigi
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 5514

Representative Information

Representative Customer Number::	05514
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Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Continuation of	09/986,918	11/13/2001

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	348713/2000	11/15/2000	Yes

Assignee Information

Assignee name:: CANON KABUSHIKI KAISHA
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City of mailing Address:: Tokyo
Country of mailing address:: Japan